

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 11, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG754537367

LABORATORY GROWN DIAMOND

EMERALD CUT

11.66 X 8.15 X 5.50 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

5.10 CARATS

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG754537367

PROPORTIONS

Thin

64%

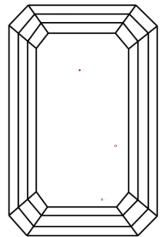
16.5%

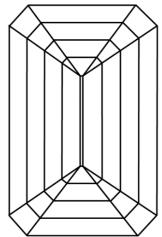
49%

67.5%

Long

CLARITY CHARACTERISTICS






KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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
EXCELLENT

EXCELLENT

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IGI



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December 11, 2025

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EMERALD CUT

11.66 X 8.15 X 5.50 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

5.10 CARATS

E

VS 1

67.5%

64%

Thin

Long

EXCELLENT

EXCELLENT

NONE

 LG754537367

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

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